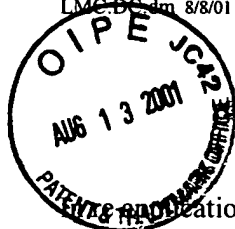


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Terry L. Gilton and Li Li

Art Unit: 2814

Application No. 09/321,518

CERTIFICATE OF MAILING

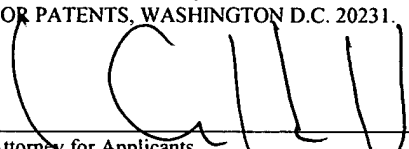
Filed: May 27, 1999

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on August 8, 2001, as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, WASHINGTON D.C. 20231.

For: SEMICONDUCTOR FABRICATION
METHODS AND APPARATUS

Examiner: B. Souw

Date: August 8, 2001


Attorney for Applicants

TRANSMITTAL LETTER

COMMISSIONER FOR PATENTS
WASHINGTON, DC 20231


Enclosed for filing in the application referenced above are the following:

- ☒ Response.
- ☒ The Director is hereby authorized to charge any additional fees that may be required, or credit over-payment, to Account No. 02-4550. A copy of this sheet is enclosed.
- ☒ Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

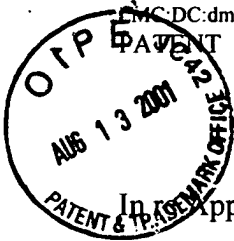
KLARQUIST SPARKMAN, LLP

By


Lisa M. Caldwell
Registration No. 41,653

One World Trade Center, Suite 1600
121 S.W. Salmon Street
Portland, Oregon 97204
Telephone: (503) 226-7391
Facsimile: (503) 228-9446

cc: Docketing



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of: Terry L. Gilton and Li Li

Application No. 09/321,518

Filed: May 27, 1999

For: SEMICONDUCTOR FABRICATION
METHODS AND APPARATUS

Examiner: W. Louie

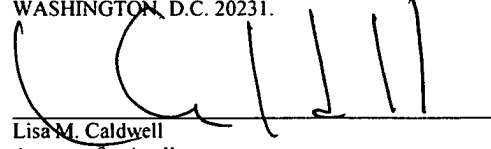
Date: August 8, 2001

Art Unit: 2814

AUG 17 2001

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Lisa M. Caldwell
Attorney for Applicants

COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

RESPONSE

This responds to the Office action, dated June 6, 2001. A three-month period for reply was set, making a response due on or before September 6, 2001.

REMARKS

I. Rejection of Claim 47 Under 35 U.S.C. § 112, First Paragraph

Claim 47 is rejected under 35 U.S.C. § 112, first paragraph, as allegedly not supported by the disclosed specification (the Examiner refers to recitation of "95% by volume" in claim 47). Because the recited language is explicitly recited in the specification, Applicants traverse the rejection and request that it be withdrawn.

Specifically, on page 8, lines 29-31 of the specification, support can be found through the statement "the concentration of the gas in the solvent is preferably at least from about 10% to about 95% gas to solvent by volume." Consequently, the § 112 rejection is improper.